



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 9011

Toshiharu TANAKA et al.

Group Art Unit: 2881

Application No.: 10/820,732

Examiner: Phillip A. JOHNSTON

Filed: April 9, 2004

Attorney Dkt. No.: 107350-00008

For: SUBSTRATE PROCESSING APPARATUS AND MAINTENANCE METHOD
THEREFOR

**PRELIMINARY AMENDMENT FILED WITH A REQUEST FOR
CONTINUED EXAMINATION (RCE) UNDER 37 C.F.R. § 1.114**

MAIL STOP RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: **OCTOBER 3, 2007**

Sir:

Coupled with the filing of a Request for Continued Examination, Applicants request that, prior to initial examination, the above-identified application be amended as shown below.

This paper is in reply to the outstanding Final Office Action dated July 3, 2007.

Amendments to the **Claims** begin on page 2.

Remarks begin on page 6